

Notice of References Cited	Application/Control No. 10/775,360		Applicant(s)/Patent Under Reexamination LIAO ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0004469	06-2001	HIMESHIMA et al.	427/66
*	B	US-2004/0238891	12-2004	NAKAMURA et al.	257/350
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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	N	WO 9708744 A1	03-1997	WIPO	NAKAMURA et al.	H01L 21/28
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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